

Notice of References Cited

Application/Control No.

09/629,780

Applicant(s)/Patent Under
Reexamination
LIU ET AL.

Examiner

Marcos D. Pizarro-Crespo

Art Unit

2814

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,960,284	09-1999	Lin et al.	438/259
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	JP 08274198 A	10-1996	Japan	KIM et al.	H01L 21/8238
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Jaeger, Vol.V: Introduction to Microelectronic Fabrication, Modular Series on Solid Devices; 1998; Addison-Wesley Publishing Company; Reading, Massachusetts; pp.178
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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